



Leica Absolute Distance Meter

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Leica Disto-Pro ranging device

- Used during SBMD and NMSD tests for radius of curvature measurements.
- Time of flight ranging device.
- +/- 2mm accuracy.
- 1.5 to 50 meters range.
- Works best with diffuse targets.
- Compact.
- Inexpensive.



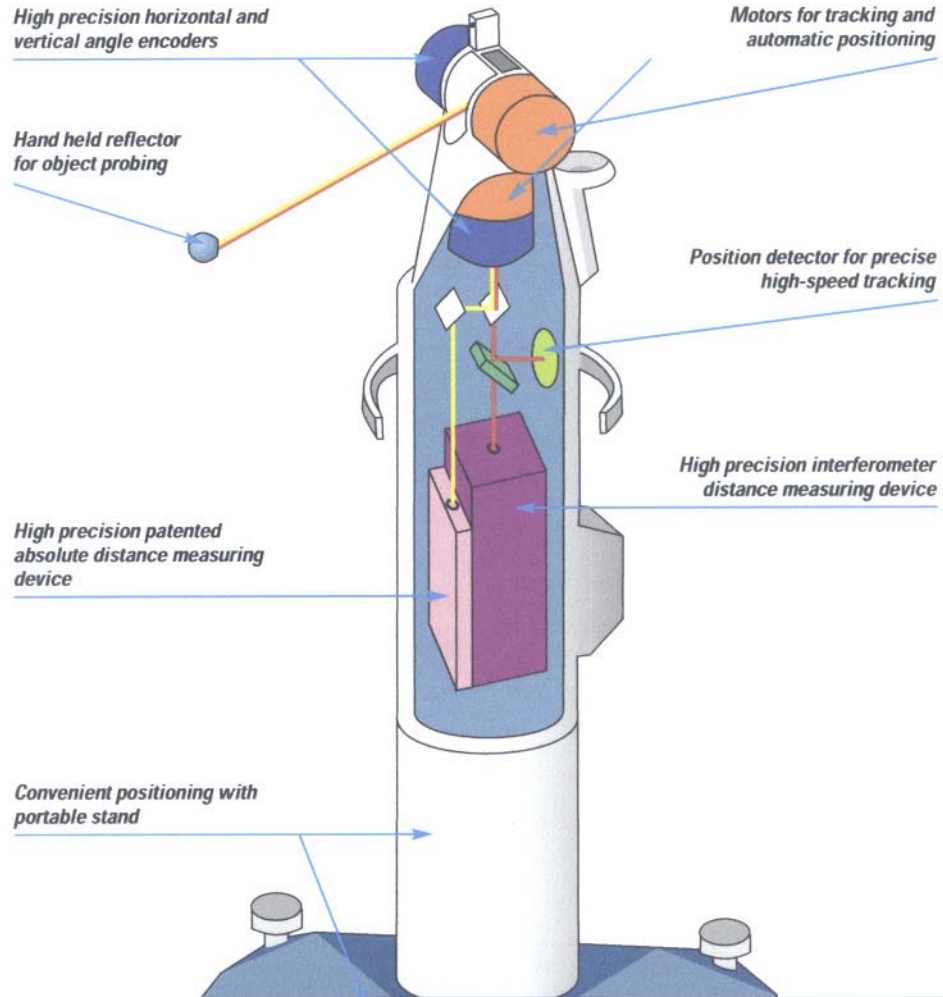


Requirements for measuring AMSD radius of curvature



- **Remote measurement device to be located at or near ROC.**
- **Absolute distance measurement or ranging device.**
- **1 micron measurement resolution.**
- **Better than 25 microns measurement accuracy.**
- **Better than 25 microns measurement repeatability.**
- **Greater than 50 meters range.**
- **Specular surface and corner cube.**
- **Fast sample rate.**
- **Compact.**
- **Easy to use.**

Leica laser tracker



CPU, power supply, and ADM



ADM on hexapod



Ranging system principle

Distance D , is determined by measuring the phase angle between the transmitted sine wave and the received sine wave.

The relationship between phase angle ϕ_r , time delay t_r , and modulation frequency f_0 , is:

$$t_r = \phi_r / 2\pi f_0$$

$$D = C t_r / 2 = C \phi_r / 4\pi f_0$$

$$D_0 = N_0 C / 2f_0$$



ADM description



IR laser diode 780nm (1mW max output)

Visible laser diode for pointing

Polarization modulation

External modulation with LiTaO₃ crystal @700-900 MHz

Differential signal detection

Detection of the same signal (same phase position)

Frequency Shift ==> 0° Phase

Minimal measurement distance 1.5 m due to minimum bandwidth of 150 MHz

Maximum measurement range 50 m

Distance measurement resolution 1 μm

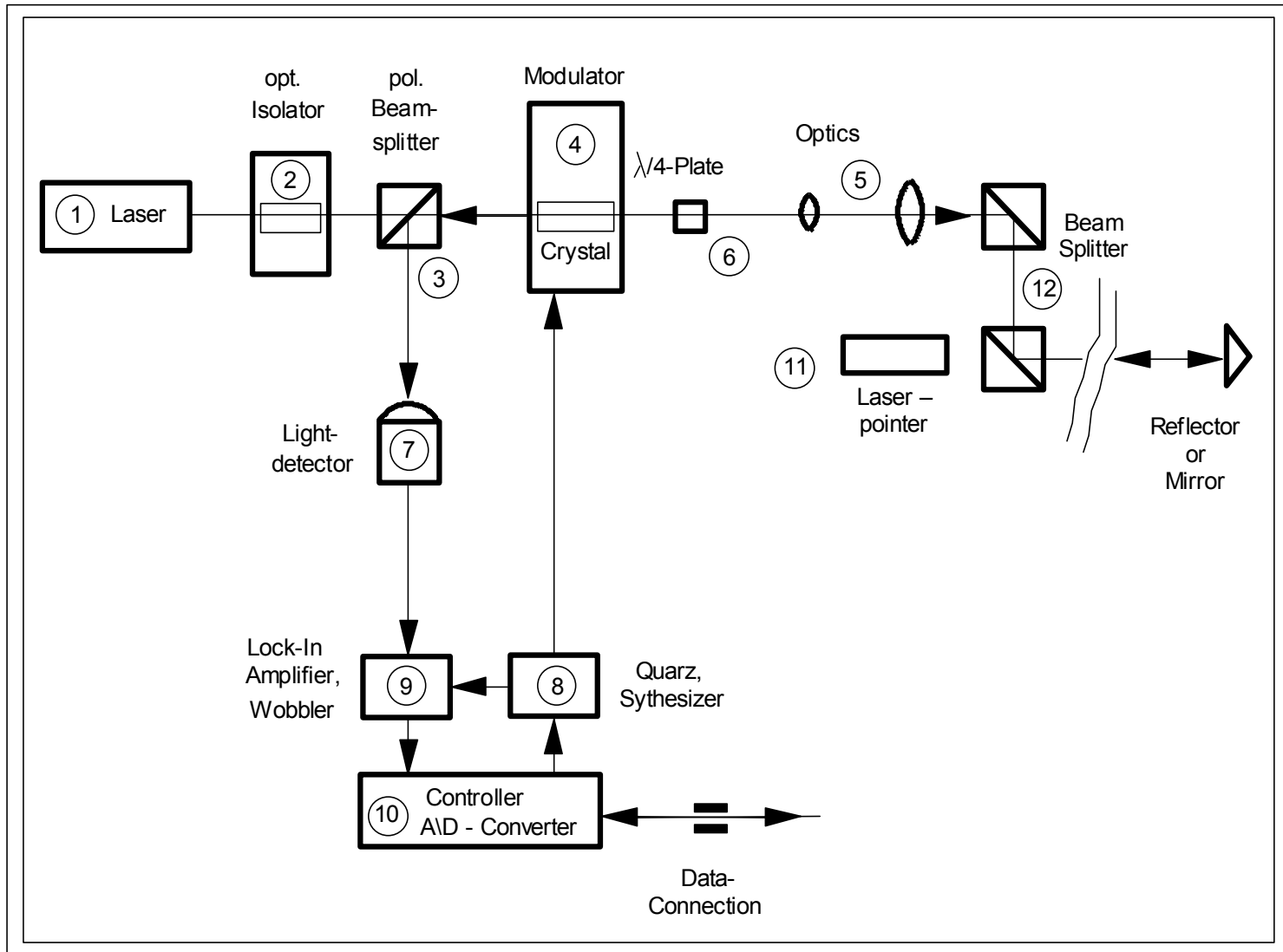
Distance measurement accuracy better than 50 μm.

400 x 120 x 40 mm (L x H x T)

2 kg

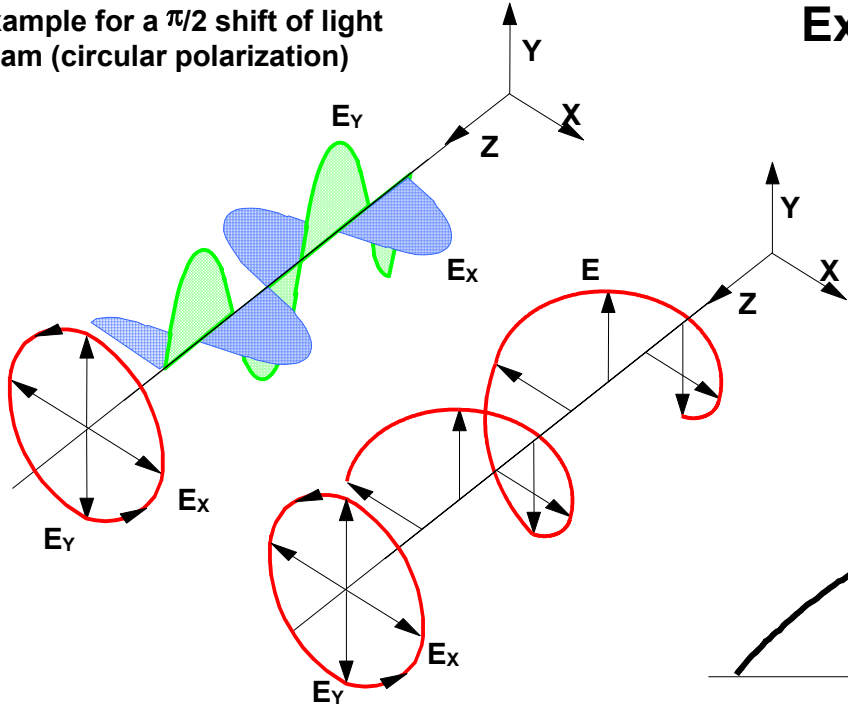


ADM schematic



ADM - Modulation methods

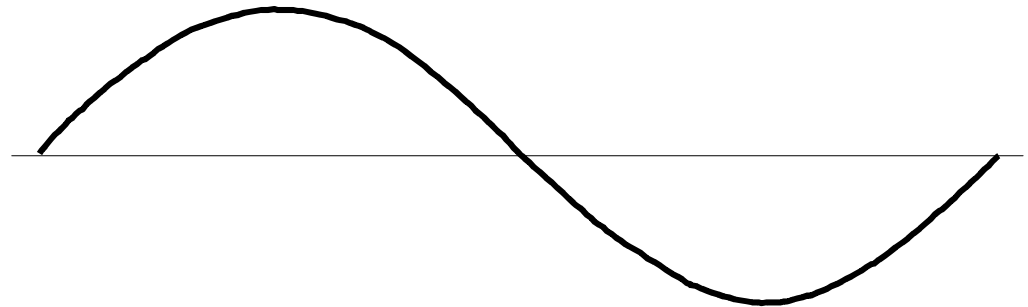
Example for a $\pi/2$ shift of light beam (circular polarization)



External modulation with LiTaO₃ crystal

- not directly influencing the laser
- using non linearity effects
- beam velocity is different at different axis E_x and E_y

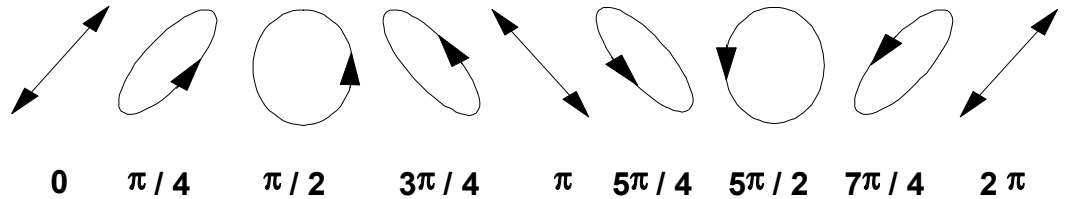
Modulation Wave



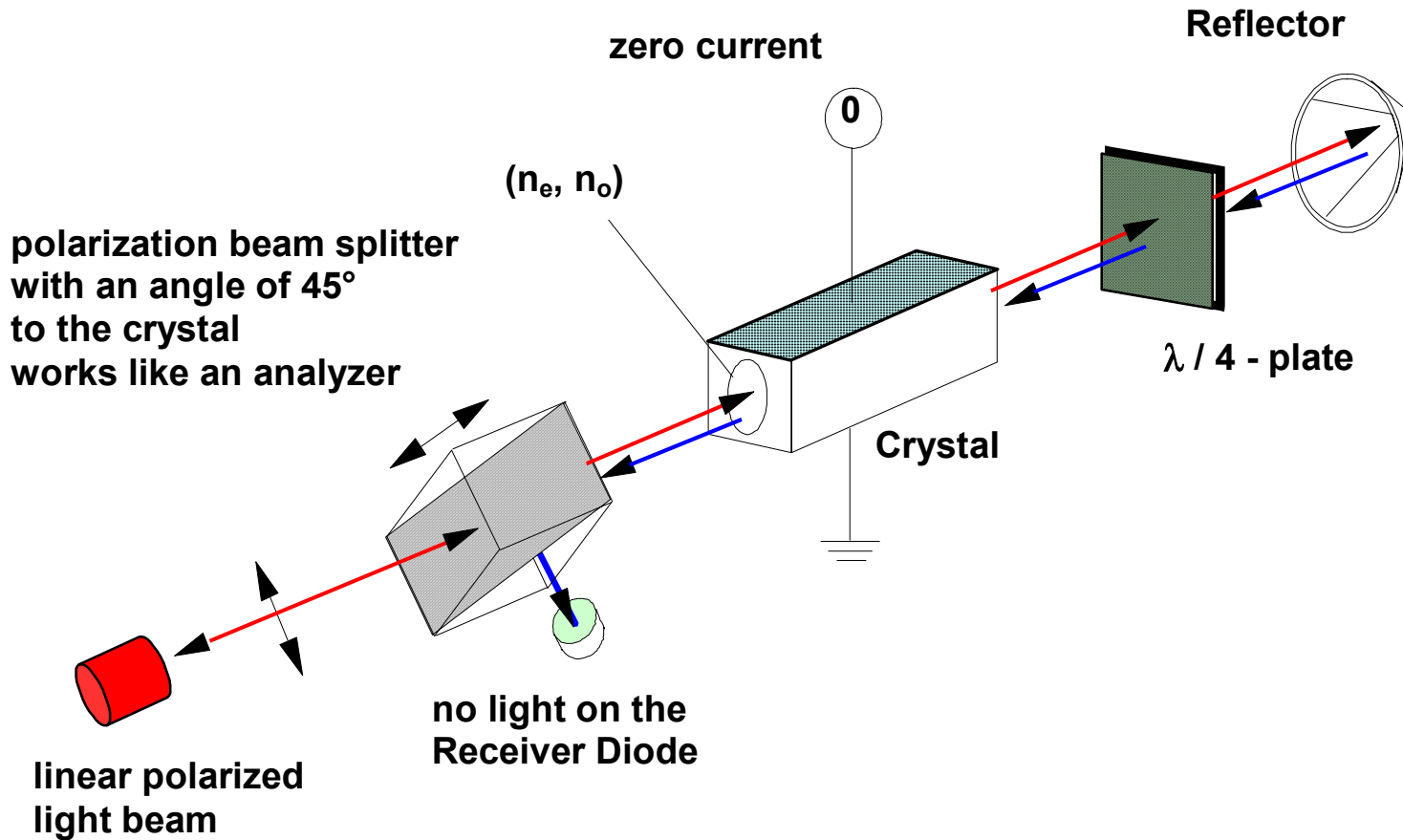
Polarization Modulation

systematical change of the beam shift by an electronic oscillation circuit

high frequency 700 - 900 MHz

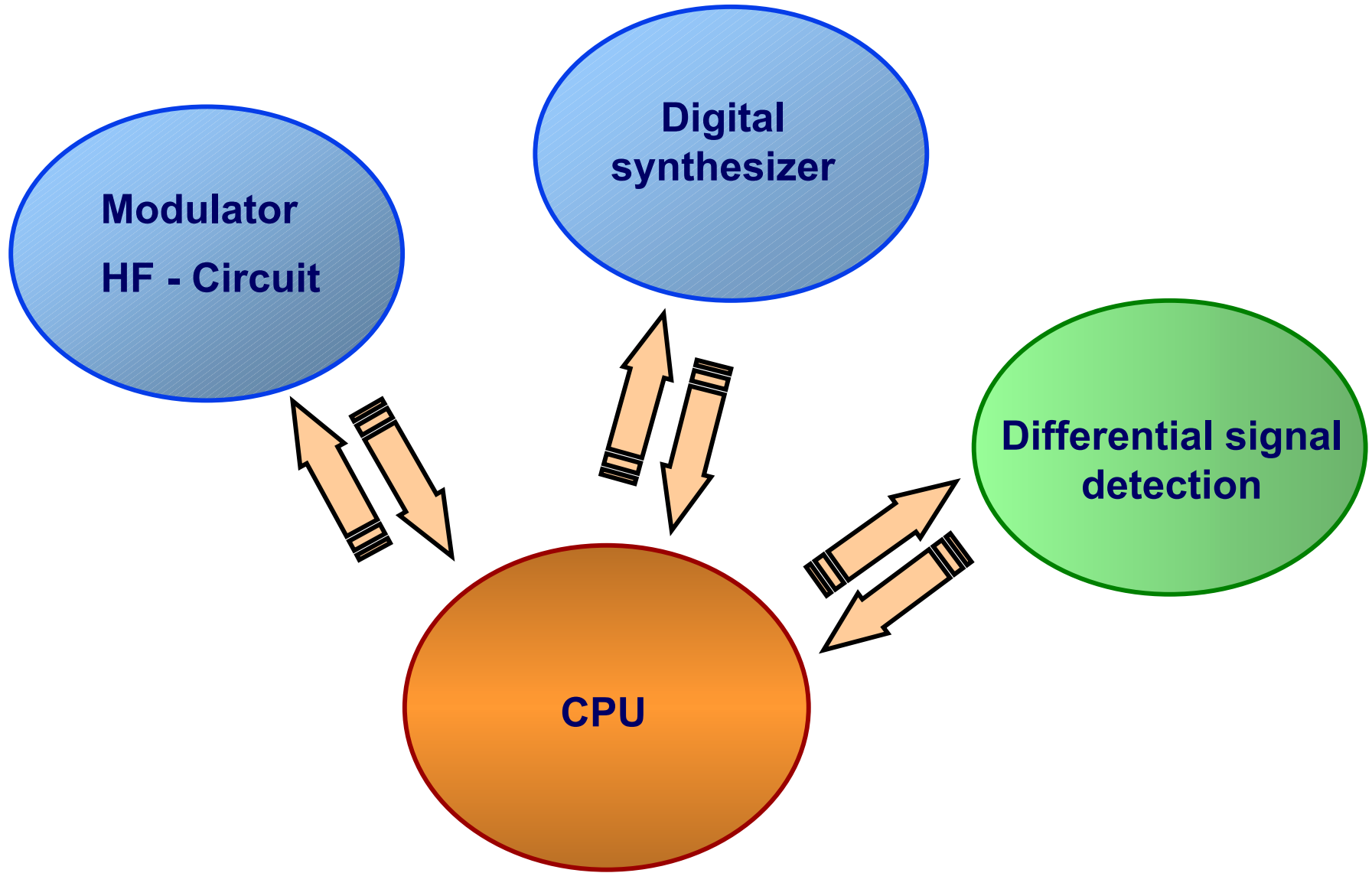


ADM - Beam Pass and Phase Control





Overview - Major Functionality Blocks





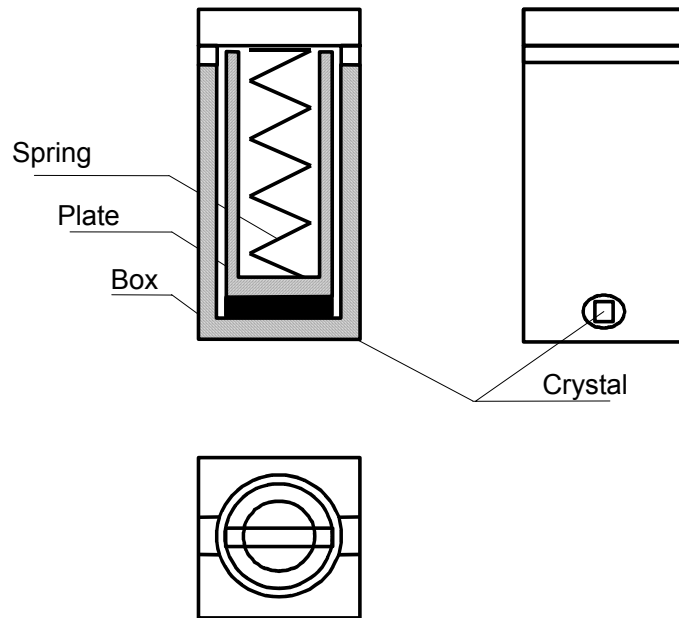
Modulator - High Frequency Circuit



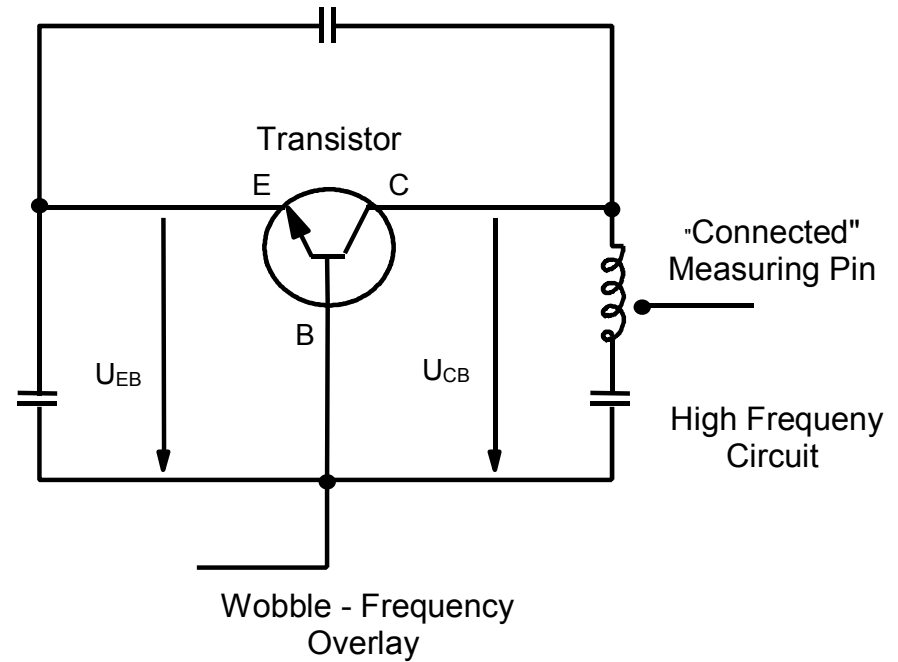
Systematical influencing of the refraction indices n_e and n_o of the crystal

High frequency with enough power

Optimized modulation voltage \Rightarrow enough modulation strength



Back - Coupling (same phase)





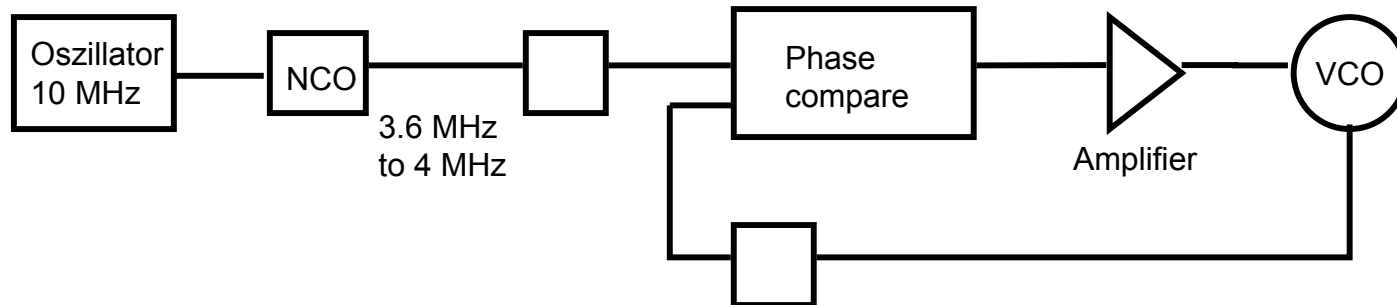
Digital synthesizer



Synthesizer for flexible and defined frequency movement

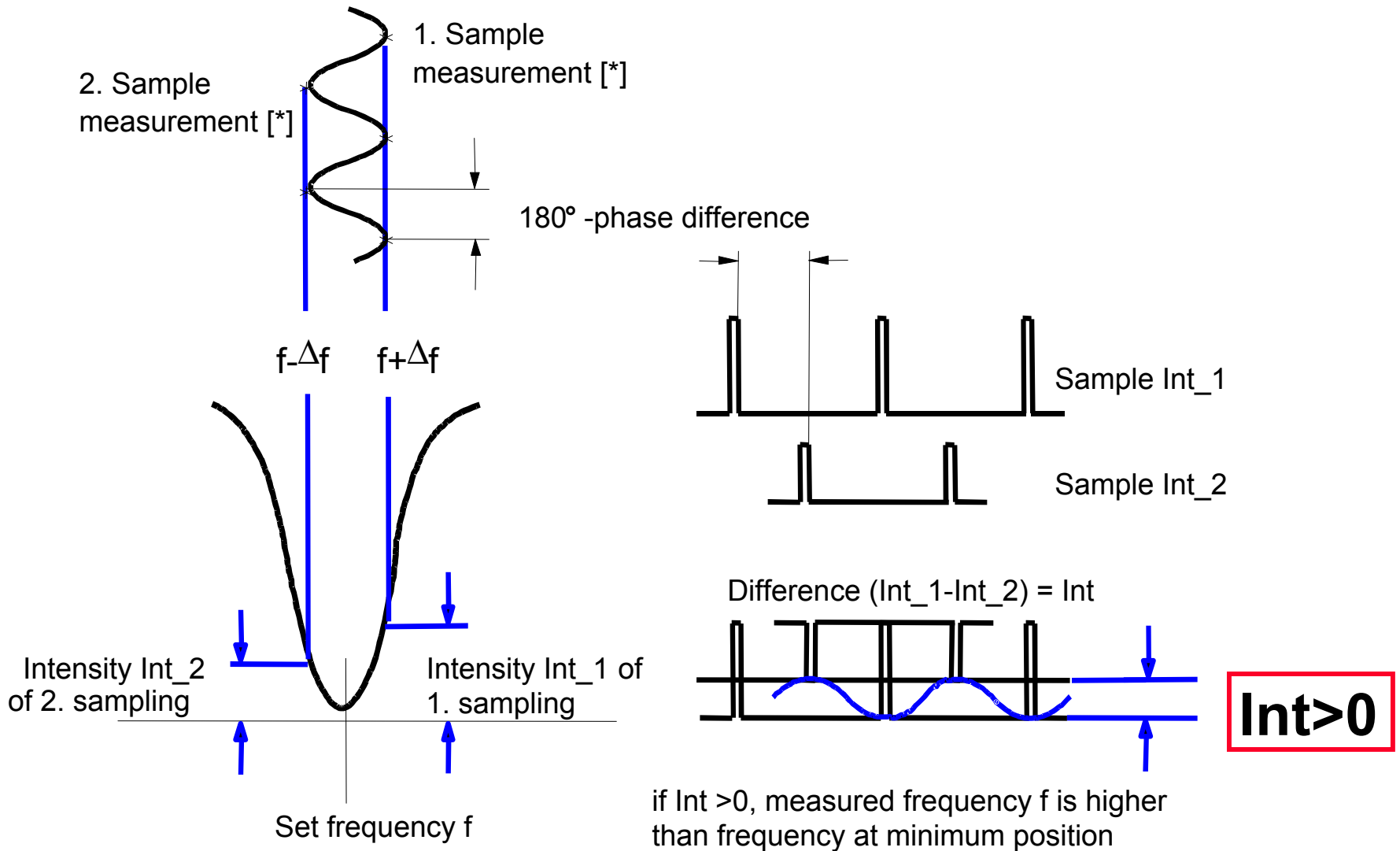
Very short reaction time

Very small frequency steps (system resolution)



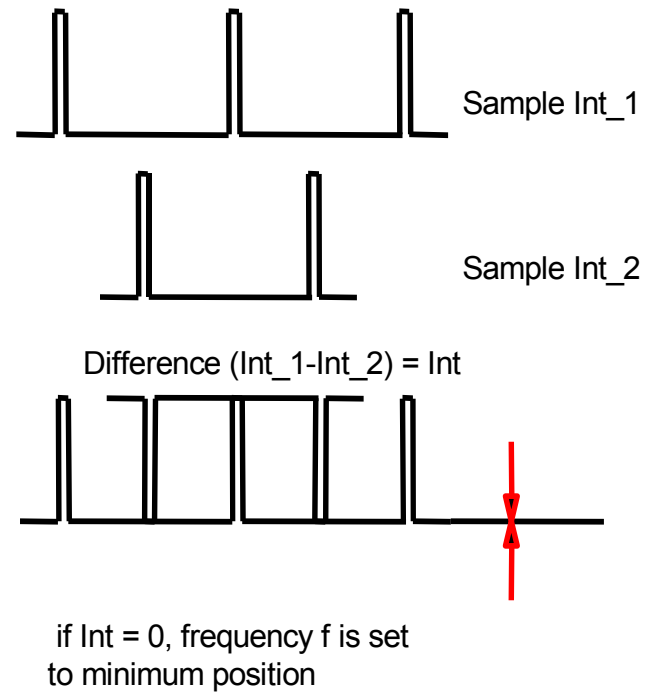
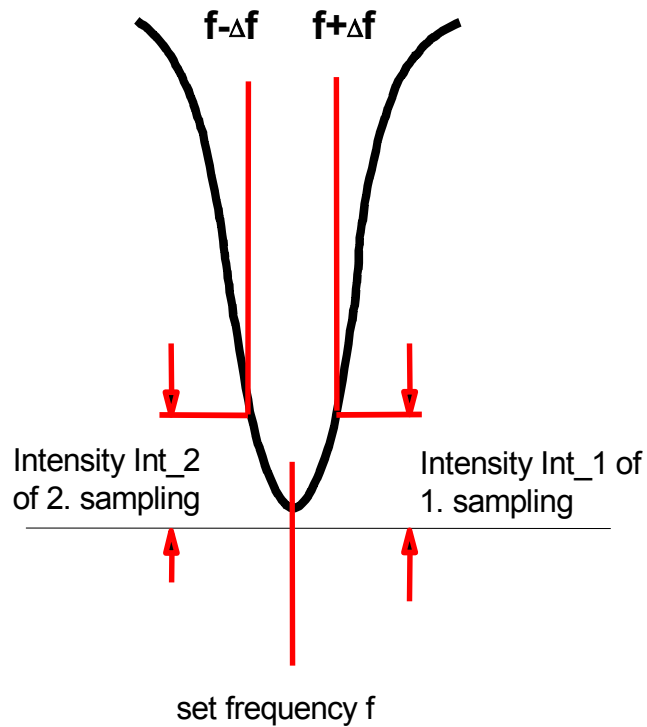


ADM - Differential Signal Detection





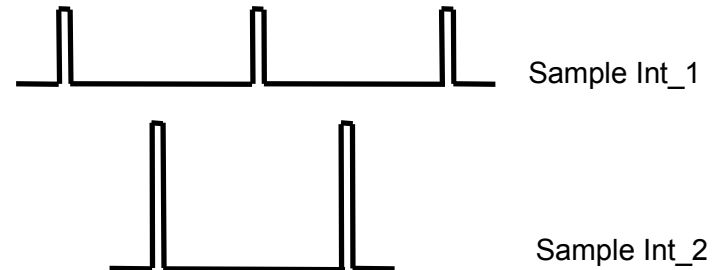
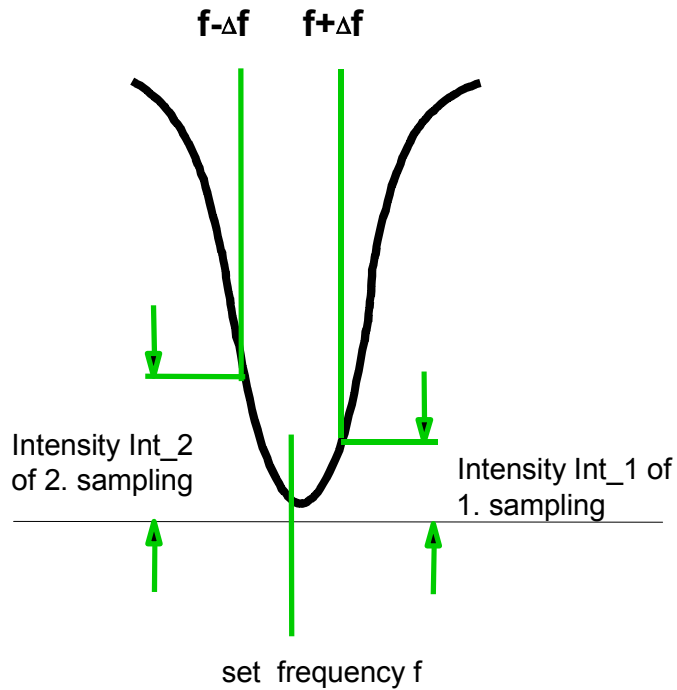
ADM - Differential Signal Detection



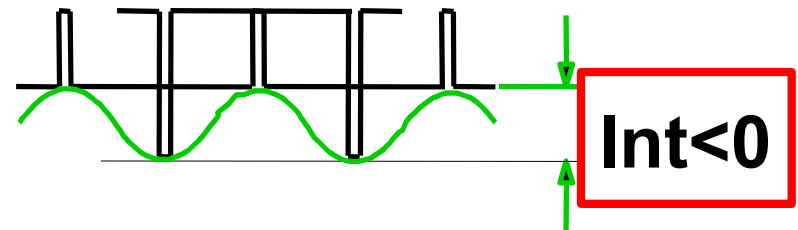
Int=0



ADM - Differential Signal Detection



Difference $(Int_1 - Int_2) = Int$



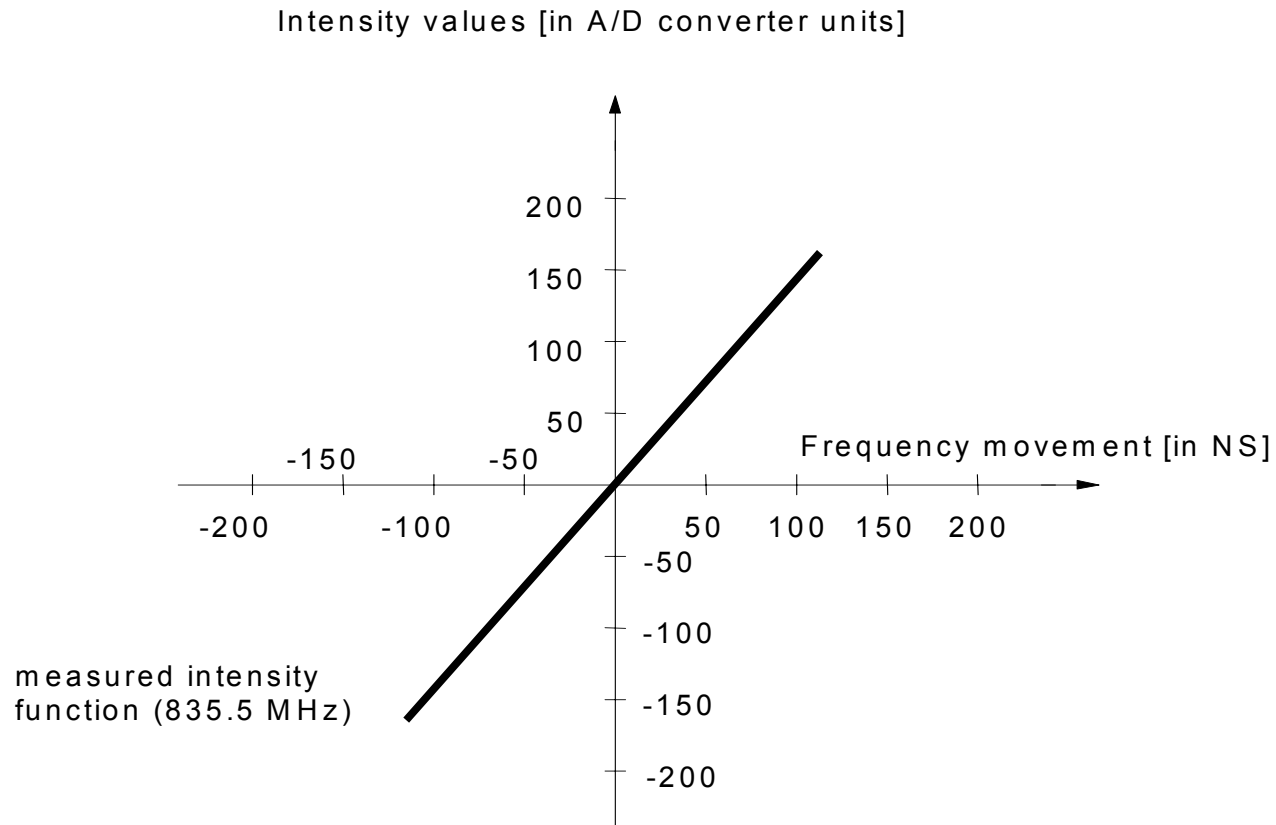
if $Int < 0$, measured frequency f is smaller than frequency at minimum position



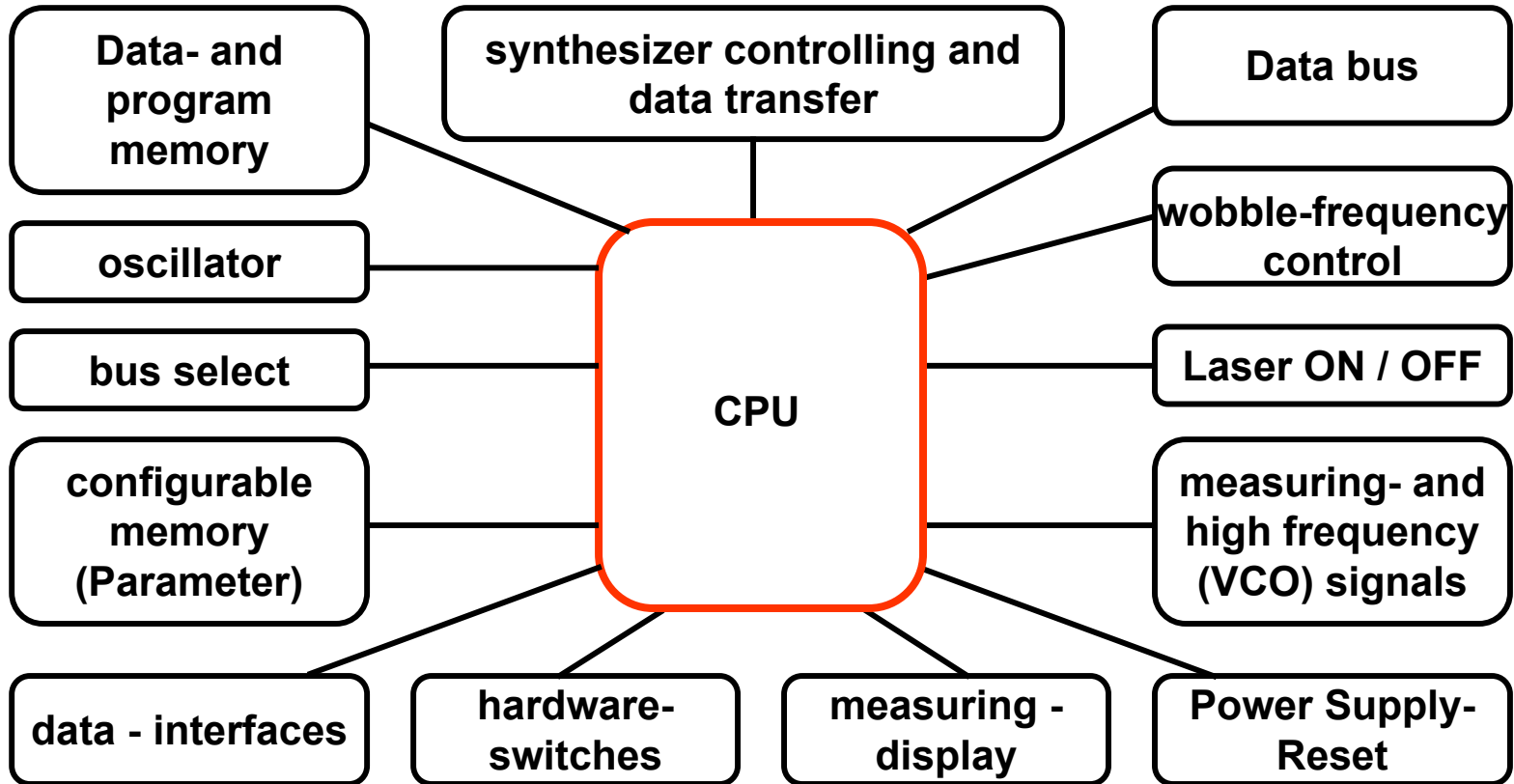
Sampling along a Minimum Position



Using difference method to sample along a minimum position, the intensity values will follow a line

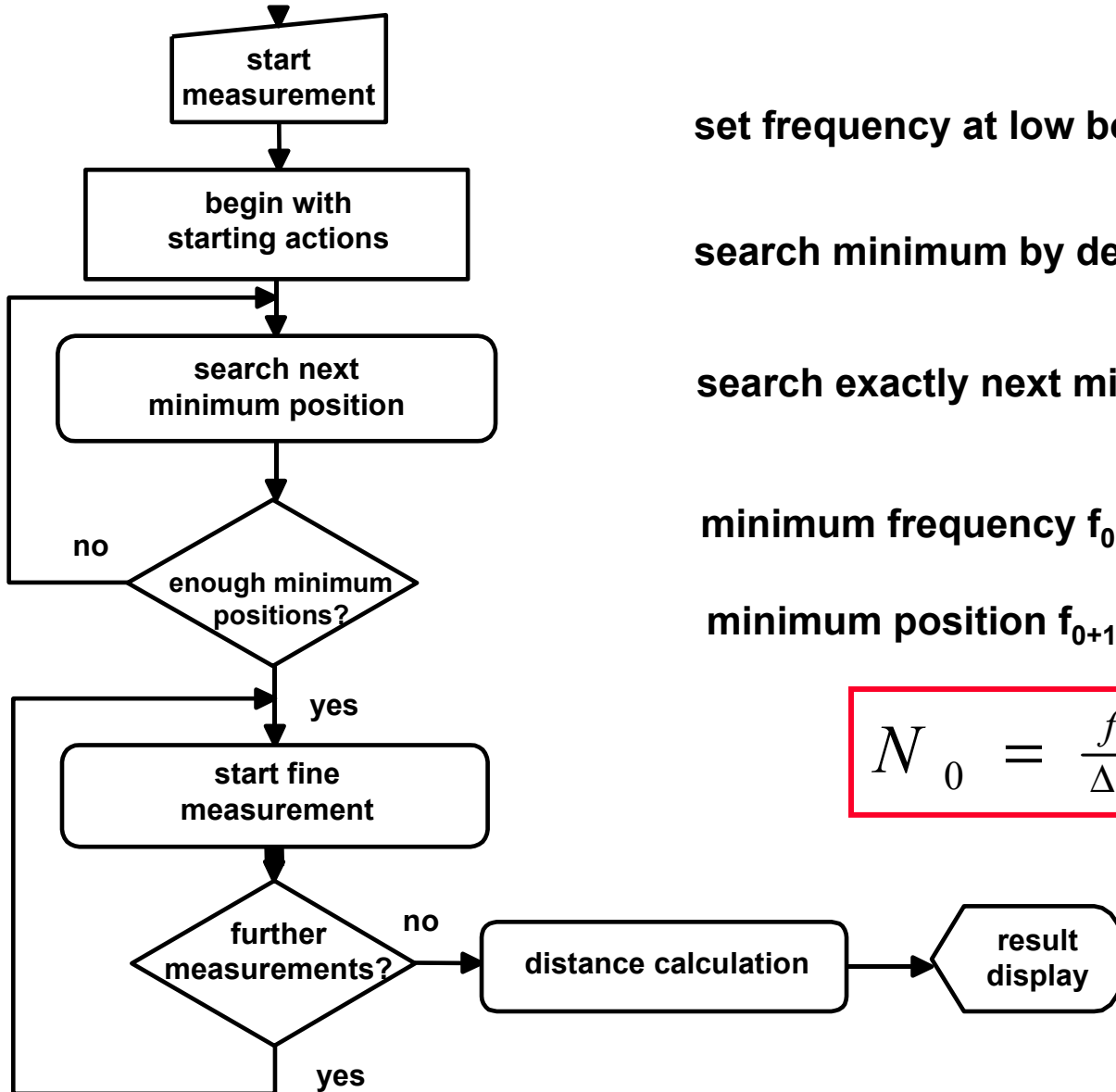


Micro - Controller Functionality





Measurement flow and distance calculation



set frequency at low boarder of modulation band

search minimum by defined frequency movement

search exactly next minimum position

minimum frequency f_0

minimum position f_{0+1}

$$\Delta f = f_{0+1} - f_0$$

$$N_0 = \frac{f_0}{\Delta f}$$

or

$$N_1 = \frac{f_1}{\Delta f}$$

$$D_0 = \frac{N_0 \cdot c}{2 \cdot f_0}$$



Accuracy depends on refractive index of air between the ADM and the target.

Refractive Index

- **T = air temperature in degrees Celsius**
- **P = pressure in millimeters of Mercury**
- **R = relative humidity in percent**

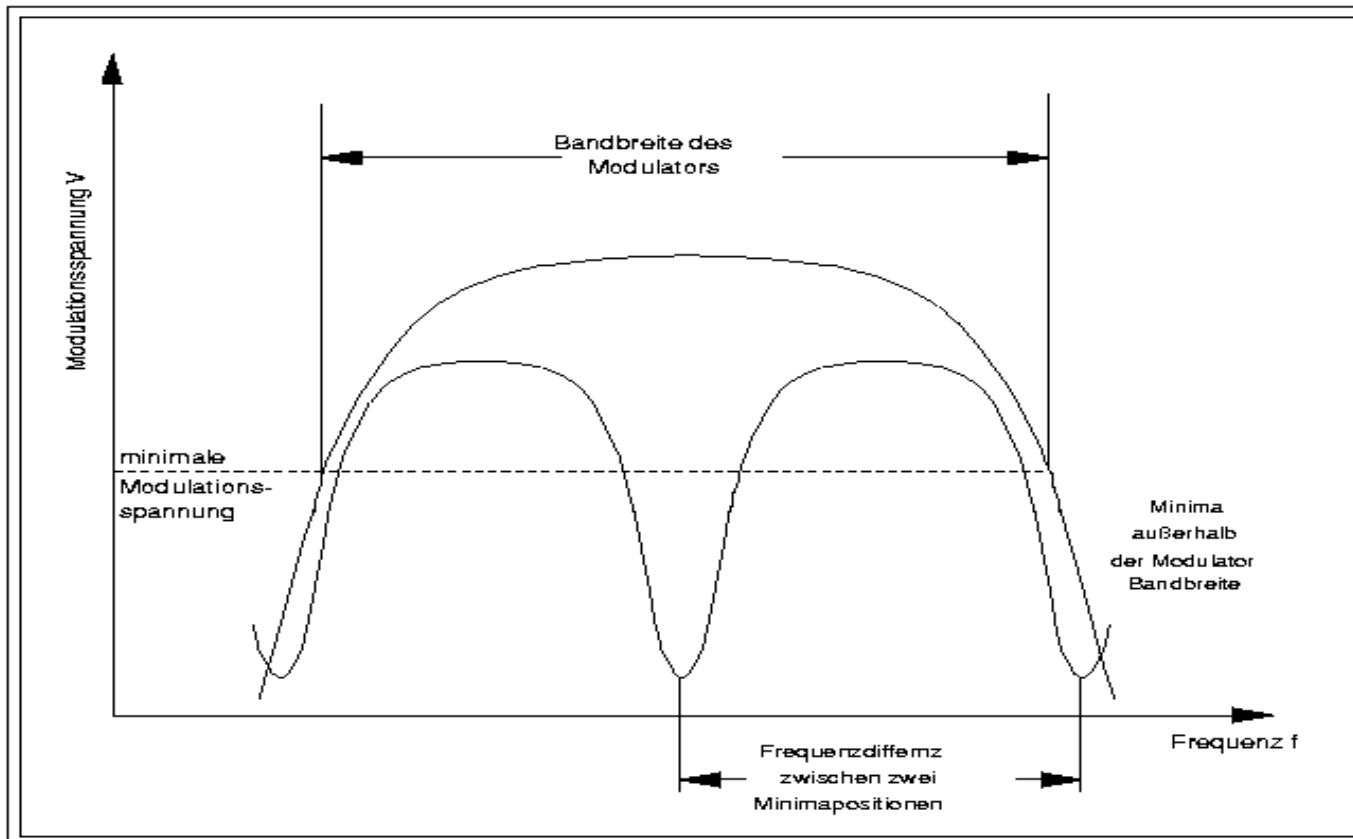
$$N_{Gr} = 0.3889479 \cdot P \cdot \left[\frac{1 + 10^{-6} \cdot P \cdot (0.817 - 0.0133 \cdot T)}{1 + 0.0036610 \cdot T} \right] - 556.68 \cdot 10^{-6} \cdot R \cdot 10^{\frac{7.5 \cdot T}{T+237.3} + 0.6609}$$

Shortest Distance

Limitations are related to:

Bandwidth of the modulator of 150 MHz

Modulation frequency





ADM measurement output



ADM Measurement

Refraction = 1.00027529886

A = -49849.000000

Dist. [m]	C	K [um]	P [um]	f [Hz]	M [m]	SD [um]
20.465532	124	-3	2	840019528	20.465532	0.000000000
20.465532	124	0	1	840019472	20.465532	0.000000000
20.465534	125	-1	2	840019472	20.465532	1.168007728
20.465534	124	-1	2	840019472	20.465533	1.168007728
20.465534	124	-1	2	840019472	20.465533	1.118282261
20.465532	123	-3	2	840019528	20.465533	1.087356019
20.465532	123	-3	2	840019528	20.465532	1.066240300
20.465534	124	0	2	840019416	20.465533	1.081365031
20.465534	123	-1	1	840019472	20.465533	1.092571186
20.465534	124	0	2	840019416	20.465533	1.054326627
20.465534	124	0	2	840019416	20.465533	1.000222061
20.465534	124	0	2	840019416	20.465533	0.996080337



Acceptance test methods



Repeatability test

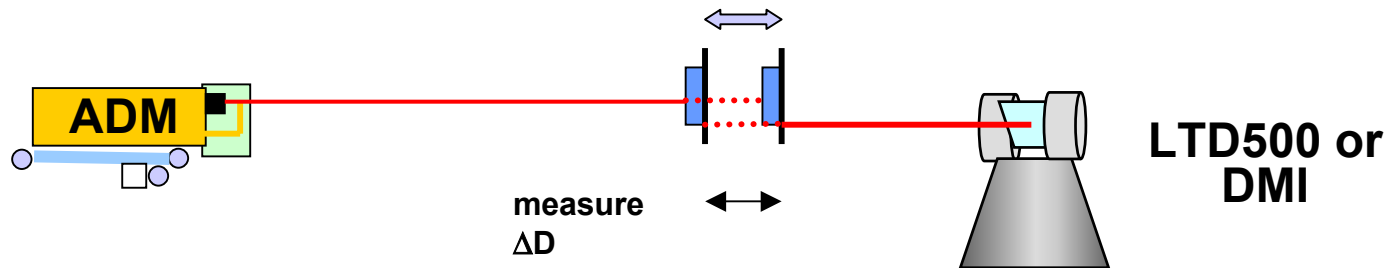
S.D. of 30 measurements to a corner cube $<25 \mu\text{m}$

S.D. of 30 measurements to a mirror $<50 \mu\text{m}$

Relative accuracy test

20 distance measurements to a corner cube, compare distance with LTD500, deviation $\Delta D <25 \mu\text{m}$

20 distance measurements to a mirror, compare distance with LTD500, deviation $\Delta D <50 \mu\text{m}$





Acceptance test methods (continue)

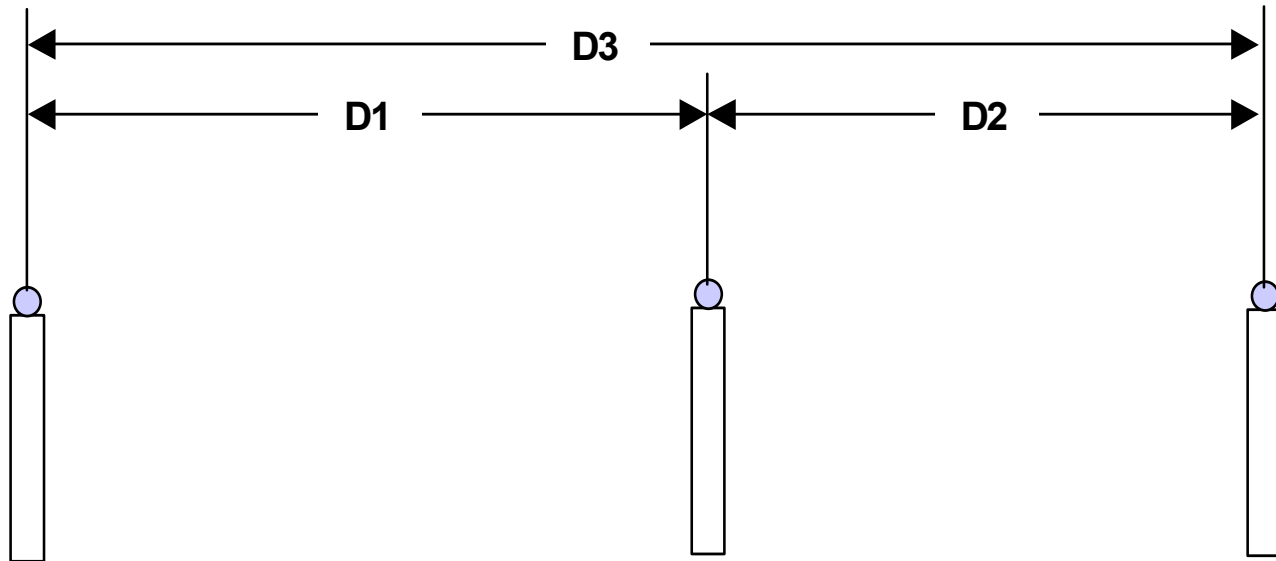


ADM offset determination (LTD500 required)

3 distances to be measured from both directions with LTD500

3 distances to be measured from both directions with ADM

Deviation between $(D1 + D2)$ and $D3 < 35 \text{ um}$





Acceptance test methods (continue)

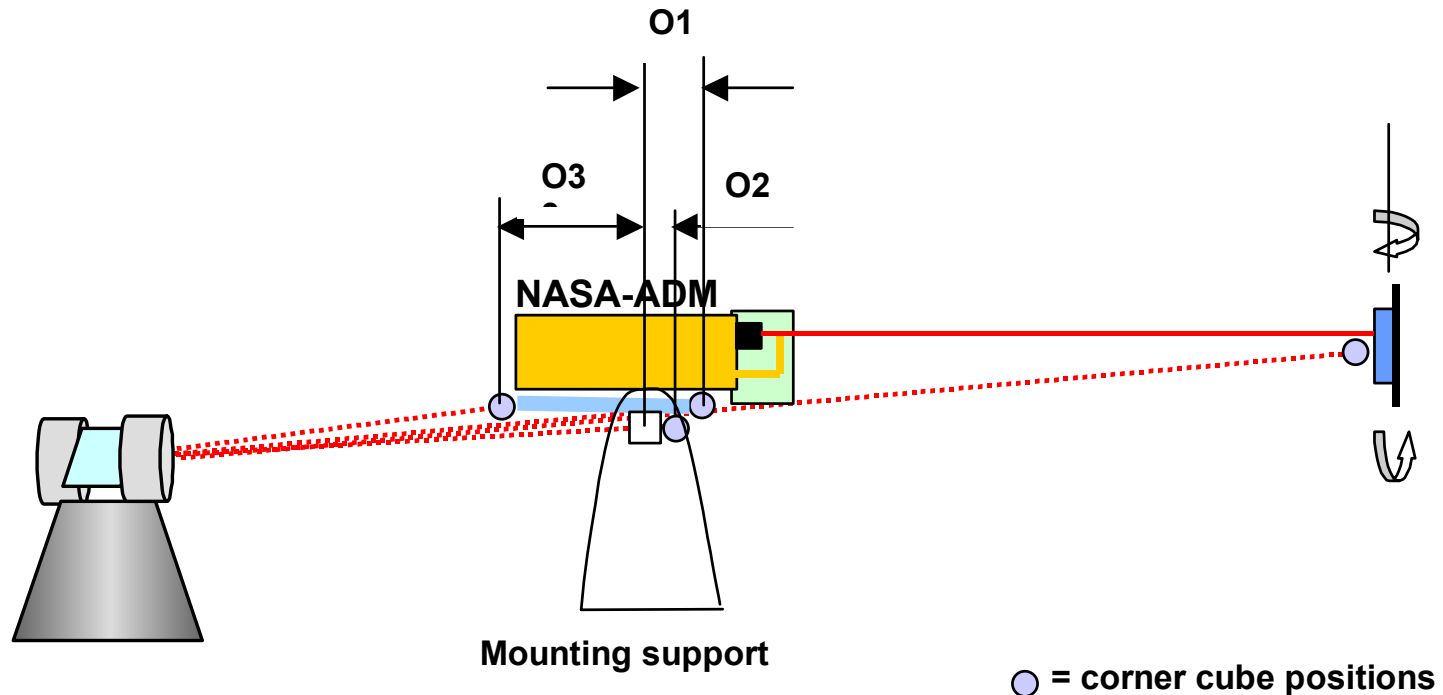


Absolute distance accuracy test (LTD500 required)

Measure 3 distances between 3 points with LTD500

Measure 3 distances between 3 points with ADM

Deviation between $(D1 + D2)$ and $D3 < 35 \mu\text{m}$



Acceptance test results

	Requirements	ADM s/n 166	ADM s/n 406
Repeatability to corner cube	S.D. < 25 um	< 1.3	< 1.8
Repeatability to mirror	S.D. < 50 um	< 3.5	< 2.7
Relative accuracy to corner cube	ΔD < 25 um	< 1.1	< 1.8
Relative accuracy to mirror	ΔD < 50 um	< 19	< 35
Absolute distance accuracy	ΔD < 35 um	< 21	< 36



Conclusions



ADM measurements are very accurate and repeatable for corner cubes.

Performed cryo deformation test of Gr-Ep reaction structure with ADM.

Software interface is easy to use.

May have problem measuring to Be mirror due to polarization properties or scatter.

Currently have no method to calibrate the ADM in house.

Demo is available on Friday during tour at XRCF. Demonstrate relative accuracy with a HP DMI.